

Notice of References Cited	Application/Control No. 09/809,440		Applicant(s)/Patent Under Reexamination HOUGHAM, GARETH	
	Examiner Monica A Fontaine		Art Unit 1732	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,355,198	03-2002	Kim et al.	264/259
	B	US-5,512,131	04-1996	Kumar et al.	438/738
	C	US-5,731,253	03-1998	Sangokoya, Samuel A.	502/102
	D	US-4,254,069	03-1981	Dominguez et al.	264/51
	E	US-4,528,354	07-1985	McDougal, John R.	528/33
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Michel, B. et al. "Siloxane Polymers for High-Resolution, High-Accuracy Soft Lithography." 2000. Macromolecules. 33, No. 8. Pages 3042-3049.			
	V	Braun, Hans-G., Evelyn Meyer. "Microprinting- A new approach to study competitive structure formation on surfaces." 1999. Macromol. Rapid Commun. 20, No. 6. Pages 325-327.			
	W	Pompe, T., A. Fery, and S. Merminghaus. "Submicron Contact Printing on Silicon Using Stamp Pads." 1999. Langmuir. 15, No. 7. Pages 2398-2401.			
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.